

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**INFORMATION SHEET**

Applicant(s): Young-Sam LIM, et al.

Application No: **NEW**

Filed: December 4, 2003

For: POLISHING PAD, PLATEN, METHOD OF MONITORING, METHOD  
OF MANUFACTURING, AND METHOD OF DETECTING


Priority Claimed Under 35 U.S.C. §119 and/or 120:

COUNTRY	DATE	NUMBER
KOREA	June 16, 2003	2003-38740

Send correspondence to : HARNESS, DICKEY & PIERCE, P.L.C.  
P.O. Box 8910  
Reston, VA 20195  
(703) 668-8000

The above information is submitted to advise the United States Patent and Trademark Office of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

By   
John A. Castellano, Reg. No. 35,094  
P.O. Box 8910  
Reston, VA 20195  
(703) 668-8000

JAC:jj